

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S44	5278	(plasma same (oxygen "O.sub.2")) same (interface between) same (substrate wafer base) same (insulat\$3 dielectric oxide nitride)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 13:55
S45	258	(plasma same (oxygen "O.sub.2")) same ((interface between) near3 (substrate wafer base) near3 (insulat\$3 dielectric oxide nitride))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/08 16:06
S46	1	("5034086").PN.	US-PGPUB; USPAT	OR	OFF	2007/11/08 16:06